Application Number:	105	10551553					
Filing Date:	03-	03-Oct-2005					
Title of Invention:		PROCESS FOR FABRICATING SEMICONDUCTOR DEVICE AND METHOD FOR GENERATING MASK PATTERN DATA					
First Named Inventor/Applicant Name:	Tos	Toshihiko Tanaka					
Filer:	Ste	Stephen Alan Becker/stephanie sharrett					
Attorney Docket Number:	067	067161-0301					
Filed as Large Entity							
U.S. National Stage under 35 USC 371 I	Filing Fee	•					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	2	3	6
	Tot	Total in USD (\$)		